

PATENT  
8040-1052

**IN THE U.S. PATENT AND TRADEMARK OFFICE**

In re application of: Taishi KUBOTA et al.  
Appl. No.: **NEW NON-PROVISIONAL**  
Filed: January 26, 2004  
Title: MANUFACTURING METHOD OF SEMICONDUCTOR  
DEVICE AND OXIDIZATION METHOD OF  
SEMICONDUCTOR SUBSTRATE

**PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

January 26, 2004

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.